


Search Notes 	Application/Control No. 10544120	Applicant(s)/Patent Under Reexamination OHBAYASHI ET AL.
	Examiner JASMINE PRITCHARD	Art Unit 2614

SEARCHED			
Class	Subclass	Date	Examiner
381	174, 175	1/30/2009	J. Pritchard
381	174, 175	8/11/2009	J. Pritchard

SEARCH NOTES		
Search Notes	Date	Examiner
Inventor name searches: Ohbayashi, Yauda, Saeki, Komai, Kagawa	1/28/2009	J. Pritchard
Oxide and Nitride, silicon film, layers	1/28/2009	J. Pritchard
Personal consultation with Suhan Ni	1/29/2009	J. Pritchard
Personal consultation with Suhan Ni	8/10/2009	J. Pritchard

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

/JASMINE PRITCHARD/
Examiner,Art Unit 2614